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| B/O Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant | Atty. Docket Number | Serial Number |
| | EM/PENG/6533 | New Application |
| | Applicant | |
| | Cheng-Jien PENG et al. | |
| | Filing Date | Group |
| | Herewith - 2/15/01 | Unassigned |



U.S. Patent Documents

| Examiner Initial | Document Number | Date | Patentee/Applicant | Class | Subclass | Filing Date if Appropriate |
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Foreign Patent Documents

| Examiner Initial | Document Number | Publication Date | Country/Agency | Class | Subclass | Translation | |
|------------------|-----------------|------------------|----------------|-------|----------|-------------|----|
| | | | | | | Yes | No |
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Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

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| | Micromachined Low-Loss Microwave Switches; Z. Jamie Yao et al., IEEE Journal of Microelectromechanical Systems, Vol. 8, No. 2, June 1999, pgs. 129-134 |
| | Effects of Capacitors, Resistors and residual Charge On The Static and Dynamic Performance of Electrostatically-Actuated Devices, E. K. Chan et al., SPIE, Vol. 3680, March-April, pgs. 120-131 |
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| Examiner | Date Considered 7/11/02 |
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